

# New 3-D transistors promising future chips, lighter laptops

December 6 2011, by Emil Venere

---

(PhysOrg.com) -- Researchers from Purdue and Harvard universities have created a new type of transistor made from a material that could replace silicon and have a 3-D structure instead of conventional flat computer chips.

The approach could enable engineers to build faster, more compact and efficient [integrated circuits](#) and lighter laptops that generate less heat than today's. The transistors contain tiny [nanowires](#) made not of silicon, like conventional transistors, but from a material called indium-gallium-arsenide.

The device was created using a so-called "top-down" method, which is akin to [industrial processes](#) to precisely etch and position components in transistors. Because the approach is compatible with conventional [manufacturing processes](#), it is promising for adoption by industry, said Peide "Peter" Ye, a professor of electrical and [computer engineering](#) at Purdue.

A new generation of silicon computer chips, due to debut in 2012, will contain transistors having a vertical structure instead of a conventional flat design. However, because silicon has a limited "[electron mobility](#)" - how fast electrons flow - other materials will likely be needed soon to continue advancing transistors with this 3-D approach, Ye said.

Indium-gallium-arsenide is among several promising semiconductors being studied to replace silicon. Such semiconductors are called III-V

materials because they combine elements from the third and fifth groups of the periodic table.

"Industry and academia are racing to develop transistors from the III-V materials," Ye said. "Here, we have made the world's first 3-D gate-all-around transistor on much higher-mobility material than silicon, the indium-gallium-arsenide."

Findings will be detailed in a paper to be presented during the International Electron Devices Meeting on December 5-7 in Washington, DC. The work is led by Purdue doctoral student Jiangjiang Gu; Harvard doctoral student Yiqun Liu; Roy Gordon, Harvard's Thomas D. Cabot Professor of Chemistry; and Ye.

Transistors contain critical components called gates, which enable the devices to switch on and off and to direct the flow of electrical current. In today's chips, the length of these gates is about 45 nanometers, or billionths of a meter. However, in 2012 industry will introduce silicon-based 3-D transistors having a gate length of 22 nanometers.

"Next year if you buy a computer it will have the 22-nanometer gate length and 3-D silicon transistors," Ye said.

The 3-D design is critical because the 22-nanometer gate lengths will not work in a flat design.

"Once you shrink gate lengths down to 22 nanometers on silicon you have to do more complicated structure design," Ye said. "The ideal gate is a necklike, gate-all-around structure so that the gate surrounds the transistor on all sides."

The nanowires are coated with a "dielectric," which acts as a gate. Engineers are working to develop transistors that use even smaller gate

lengths, 14 nanometers, by 2015.

However, further size reductions beyond 14 nanometers and additional performance improvements are likely not possible using silicon, meaning new designs and materials will be needed to continue progress, Ye said.

"Nanowires made of III-V alloys will get us to the 10 nanometer range," he said.

The new findings confirmed that the device made using a III-V material has the potential to conduct [electrons](#) five times faster than silicon.

Creating smaller transistors also will require finding a new type of insulating layer essential for the devices to switch off. As gate lengths shrink smaller than 14 nanometers, the silicon dioxide insulator used in conventional transistors fails to perform properly and is said to "leak" electrical charge.

One potential solution to this leaking problem is to replace silicon dioxide with materials that have a higher insulating value, or "dielectric constant," such as hafnium dioxide or aluminum oxide.

In the new work, the researchers applied a dielectric coating made of aluminum oxide using a method called atomic layer deposition. Because atomic layer deposition is commonly used in industry, the new design may represent a practical solution to the coming limits of conventional silicon transistors.

Using atomic layer deposition might enable engineers to design [transistors](#) having thinner oxide and metal layers for the gates, possibly consuming far less electricity than [silicon](#) devices.

"A thinner dielectric layer means speed goes up and voltage

requirements go down," Ye said.

The work is funded by the National Science Foundation and the Semiconductor Research Corp. and is based at the Birck Nanotechnology Center in Purdue's Discovery Park. The latest research is similar to, but fundamentally different from, research reported by Ye's group in 2009. That work involved a design called a finFET, for fin field-effect transistor, which uses a finlike structure instead of the conventional flat design. The new design uses nanowires instead of the fin design.

**More information:** First Experimental Demonstration of Gate-all-around III-V MOSFETs by Top-down Approach, [www.his.com/~iedm/](http://www.his.com/~iedm/)

## ABSTRACT

The first inversion-mode gate-all-around (GAA) III-V MOSFETs are experimentally demonstrated with a high mobility  $\text{In}_{0.53}\text{Ga}_{0.47}\text{As}$  channel and atomic-layer-deposited (ALD)  $\text{Al}_2\text{O}_3/\text{WN}$  gate stacks by a top-down approach. A well-controlled InGaAs nanowire release process and a novel ALD high-k/metal gate process has been developed to enable the fabrication of III-V GAA MOSFETs. Well-behaved on-state and off-state performance has been achieved with channel length ( $L_{ch}$ ) down to 50nm. A detailed scaling metrics study (S.S., DIBL, VT) with  $L_{ch}$  of 50nm - 110nm and fin width of 30nm - 50nm are carried out, showing the immunity to short channel effects with the advanced 3-D structure. The GAA structure has provided a viable path towards ultimate scaling of III-V MOSFETs.

Provided by Purdue University

Citation: New 3-D transistors promising future chips, lighter laptops (2011, December 6)

retrieved 19 April 2024 from

<https://phys.org/news/2011-12-d-transistors-future-chips-lighter.html>

This document is subject to copyright. Apart from any fair dealing for the purpose of private study or research, no part may be reproduced without the written permission. The content is provided for information purposes only.